



OPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Dalton et al.

Attorney Docket No.: NOVLP082

Application No.: 10/772,109

Examiner: Not Yet Assigned

Filed: February 3, 2004

Group: 1761

Title: USE OF METALLOCENES TO INHIBIT
COPPER OXIDATION DURING
SEMICONDUCTOR PROCESSING

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on September 15, 2005 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: _____

Tara Hayden

REQUEST FOR STATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant hereby requests status of the above-referenced patent application. This application was filed on February 3, 2004 and no response has been received as of this date.

Respectfully submitted,

BEYER WEAVER & THOMAS, LLP

Jeffrey K. Weaver

Registration No. 31,314

P.O. Box 70250
Oakland, CA 94612-0250